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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant : T.L. Ritzdorf, et al.
Application No. : 09/386,734 Confirmation No.: 1242
Filed : August 31, 1999
For : METHOD AND APPARATUS FOR LOW
TEMPERATURE ANNEALING OF METALLIZATION
MICRO-STRUCTURES IN THE PRODUCTION OF A
MICROELECTRONIC DEVICE

Examiner : G. Wyszmierski
Art Unit : 1742
Docket No. : 29195.8162US1
Date : October 1, 2001

Commissioner for Patents
Washington, DC 20231

AMENDMENT

Dear Commissioner:

The present amendment is being filed in response to the Office Action mailed 20 June 2001 in the above-identified application. The present amendment amends both the specification and the claims in the present application. In accordance with 37 C.F.R. §1.121, enclosed herewith is an appendix that has been marked to show the changes made by amendment.

IN THE SPECIFICATION:

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